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For the following device		And you must domonstrate continuous compli
· · ·	You must meet the following operating limit	And you must demonstrate continuous compliance with the operating limit by
4. Condenser	The average condenser outlet (product side) gas temperature in any 3-hour period must not exceed the temperature limit established according to § 63.3167(d).	i. Collecting the condenser outlet (product side) gas temperature according to §63.3168(e); ii. Reducing the data to 3-hour block averages; and iii. Maintaining the 3-hour average gas temperature at the outlet at or below the temperature limit.
 Concentrators, includ- ing zeolite wheels and rotary carbon adsorbers. 	The average desorption gas inlet temperature in any 3-hour period must not fall below the limit established according to §63.3167(e).	i. Collecting the temperature data according to § 63.3168(f); ii. Reducing the data to 3-hour block averages; and iii. maintaining the 3-hour average temperature at or above the temperature limit.
6. Emission capture system that is a PTE.	a. The direction of the air flow at all times must be into the enclosure; and either. b. The average facial velocity of air through all natural draft openings in the enclosure must be at least 200 feet per minute; or. c. The pressure drop across the enclosure must be at least 0.007 inch water, as established in Method 204 of appendix M to 40 CFR part 51.	i. Collecting the direction of air flow, and either the facial velocity of air through all natural draft openings according to §63.3168(g)(1) or the pressure drop across the enclosure according to §63.3168(g)(2); and ii. Maintaining the facial velocity of air flow through all natural draft openings or the pressure drop at or above the facial velocity limit or pressure drop limit, and maintaining the direction of air flow into the enclosure at all times.
7. Emission capture system that is not a PTE.	a. The average gas volumetric flow rate or duct static pressure in each duct between a capture device and add-on control device inlet in any 3-hour period must not fall below the average volumetric flow rate or duct static pressure limit established for that capture device according to §63.3167(f). This applies only to capture devices that are not part of a PTE that meets the criteria of §63.3165(a) and that are not capturing emissions from a downdraft spray booth or from a flashoff area or bake oven associated with a downdraft spray booth.	i. Collecting the gas volumetric flow rate or duct static pressure for each capture device according to § 63.3168(g); ii. Reducing the data to 3-hour block averages; and iii. Maintaining the 3-hour average gas volumetric flow rate or duct static pressure for each capture device at or above the gas volumetric flow rate or duct static pressure limit.

 $[69\;\mathrm{FR}\;22623,\,\mathrm{Apr}.\;26,\,2004,\,\mathrm{as}\;\mathrm{amended}\;\mathrm{at}\;72\;\mathrm{FR}\;20236,\,\mathrm{Apr}.\;24,\,2007]$

Table 2 to Subpart IIII of Part 63—Applicability of General Provisions to Subpart IIII of Part 63

You must comply with the applicable General Provisions requirements according to the following table

Citation	Citation Subject		Explanation	
§ 63.1(a)(1)–(12) § 63.1(b)(1)–(3)			Applicability to subpart IIII is also specified in §63.3081.	
§ 63.1(c)(1)	Applicability After Standard Established.	Yes.		
§ 63.1(c)(2)	Applicability of Permit Program for Area Sources.	No	Area sources are not subject to subpart IIII.	
§ 63.1(c)(5)	Extensions and Notifications	Yes.		
§ 63.1(e)	Applicability of Permit Program Before Relevant Standard is Set.	Yes.		
§ 63.2	Definitions	Yes	Additional definitions are specified in § 63.3176.	
§ 63.3(a)-(c)	Units and Abbreviations	Yes.	Q ** * *	
§ 63.4(a)(1)–(5)	Prohibited Activities	Yes.		
§ 63.4(b)–(c)	Circumvention/Fragmentation	Yes.		
§ 63.5(a)	Preconstruction Review Applicability.	Yes.		
§ 63.5(b)(1)–(6)	Requirements for Existing, Newly Constructed, and Re- constructed Sources.	Yes.		

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Citation	Subject	Applicable to subpart IIII	Explanation	
§ 63.5(d)	Application for Approval of Construction/Reconstruction.	Yes.		
§ 63.5(e)	Approval of Construction/Reconstruction.	Yes.		
§ 63.5(f)	Approval of Construction/Reconstruction Based on Prior State Review.	roval of Construction/Recon- ruction Based on Prior State		
§ 63.6(a)	Compliance With Standards and Maintenance Requirements—Applicability.	Yes.		
§ 63.6(b)(1)–(7)	Compliance Dates for New and Reconstructed Sources.	Yes	Section 63.3083 specifies the compliance dates.	
§ 63.6(c)(1)–(5)	Compliance Dates for Existing Sources.	Yes	Section 63.3083 specifies the compliance dates.	
§ 63.6(e)(1)–(2) § 63.6(e)(3)	Operation and Maintenance	Yes. Yes	Only sources using an add-on	
		100	control device to comply with the standard must complete SSMP.	
§ 63.6(f)(1)	Compliance Except During Start- up, Shutdown, and Malfunc- tion.	Yes	Applies only to sources using an add-on control device to comply with the standards.	
§ 63.6(f)(2)–(3)	Methods for Determining Compliance.	Yes.		
§ 63.6(g)(1)–(3)	Use of an Alternative Standard	Yes. No	Cubnant IIII daga nat aatabliah	
§ 63.6(h)	Compliance With Opacity/Visible Emission Standards.	NO	Subpart IIII does not establish opacity standards and does not require continuous opacity monitoring systems (COMS).	
§ 63.6(j)	Extension of Compliance Presidential Compliance Exemption.	Yes. Yes.		
§ 63.7(a)(1)		Yes	Applies to all affected sources. Additional requirements for performance testing are specified in §§ 63.3164 and 63.3166.	
§ 63.7(a)(2)	Performance Test Requirements—Dates.	Yes	Applies only to performance tests for capture system and control device efficiency at sources using these to comply with the standards. Section 63.3160 specifies the schedule for performance test requirements that are earlier than those specified in §63.7(a)(2).	
§ 63.7(a)(3)	Performance Tests Required By the Administrator.	Yes.		
§ 63.7(b)–(e)	Performance Test Require- ments—Notification, Quality Assurance, Facilities Nec- essary for Safe Testing Condi- tions During Test.	Yes	Applies only to performance tests for capture system and add-on control device effi- ciency at sources using these to comply with the standards.	
§ 63.7(f)		Yes	Applies to all test methods except those used to determine capture system efficiency.	
§ 63.7(g)–(h)	Performance Test Require- ments—Data Analysis, Rec- ordkeeping, Reporting, Waiver of Test.	Yes	Applies only to performance tests for capture system and add-on control device efficiency at sources using these to comply with the standards.	
§ 63.8(a)(1)–(3)	Monitoring Requirements—Applicability.	Yes	Applies only to monitoring of capture system and add-on control device efficiency at sources using these to comply with the standards. Additional requirements for monitoring are specified in §63.3168.	
§ 63.8(a)(4)	Additional Monitoring Requirements.	No	Subpart IIII does not have monitoring requirements for flares.	
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Citation	Subject	Applicable to subpart IIII	Explanation
63.8(c)(1)-(3)	Continuous Monitoring Systems (CMS) Operation and Maintenance.	Yes	Applies only to monitoring of capture system and add-on control device efficiency at sources using these to comply with the standards. Additional requirements for CMS operations and maintenance are
§ 63.8(c)(4)	CMS	No	specified in § 63.3168. Section 63.3168 specifies the requirements for the operation of CMS for capture systems and add-on control devices at sources using these to comply with the standards.
§ 63.89(c)(5)	COMS	No	Subpart IIII does not have opacity or visible emission standards.
§ 63.8(c)(6)	CMS Requirements	No	Section 63.3168 specifies the requirements for monitoring systems for capture systems and add-on control devices at sources using these to comply with the standards.
§ 63.8(c)(7) § 63.8(c)(8)	CMS Out-of-Control Periods CMS Out-of-Control Periods Re-	No	Section 63.3120 requires report-
	porting.		ing of CMS out-of-control peri- ods.
§ 63.8(d)–(e)	Quality Control Program and CMS Performance Evaluation.	No	Subpart IIII does not require the use of continuous emissions monitoring systems.
§ 63.8(f)(1)–(5)	Use of an Alternative Monitoring	Yes.	morning eyeleme.
§ 63.8(f)(6)	Method. Alternative to Relative Accuracy Test.	No	Subpart IIII does not require the use of continuous emissions
§ 63.8(g)(1)–(5)	Data Reduction	No	monitoring systems. Sections 63.3167 and 63.3168 specify monitoring data reduction.
§ 63.9(a)—(d) § 63.9(e)	Notification Requirements Notification of Performance Test	Yes. Yes	Applies only to capture system and add-on control device performance tests at sources using these to comply with the standards.
§ 63.9(f)	Notification of Visible Emissions/ Opacity Test.	No	Subpart IIII does not have opacity or visible emission standards.
§ 63.9(g)(1)–(3)	Additional Notifications When Using CMS.	No	Subpart IIII does not require the use of continuous emissions monitoring systems.
§ 63.9(h)	Notification of Compliance Status.	Yes	Section 63.3110 specifies the dates for submitting the notification of compliance status.
§ 63.9(i)	Adjustment of Submittal Dead- lines.	Yes	•
§ 63.9(j) § 63.10(a)	Change in Previous Information Recordkeeping/Reporting—Applicability and General Information.	Yes. Yes.	
§ 63.10(b)(1)	General Recordkeeping Requirements.	Yes	Additional requirements are specified in §§ 63.3130 and 63.3131.
§ 63.10(b)(2)(i)–(v)	Recordkeeping Relevant to Startup, Shutdown, and Mal- function Periods and CMS.	Yes	Requirements for startup, shut- down, and malfunction records only apply to capture systems and add-on control devices used to comply with the standards.
§ 63.10(b)(2)(vi)-(xi) § 63.10(b)(2)(xii) § 63.10(b)(2)(xiii)	Records	Yes. Yes. No	Subpart IIII does not require the use of continuous emissions monitoring systems.

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Citation	Subject	Subject Applicable to subpart IIII	
§ 63.10(b)(2)(xiv)		Yes.	
§ 63.10(b)(3)	Recordkeeping Requirements for Applicability Determinations.	Yes.	
§ 63.10(c)(1)–(6)	Additional Recordkeeping Requirements for Sources with CMS.	Yes.	
§ 63.10(c)(7)–(8)		No	The same records are required in § 63.3120(a)(6).
§ 63.10(c)(9)–(15)		Yes	. , , ,
§ 63.10(d)(1)	General Reporting Requirements.	Yes	Additional requirements are specified in § 63.3120.
§ 63.10(d)(2)	Report of Performance Test Results.	Yes	Additional requirements are specified in § 63.3120(b).
§ 63.10(d)(3)	Reporting Opacity or Visible Emissions Observations.	No	Subpart IIII does not require opacity or visible emissions observations.
§ 63.10(d)(4)	Progress Reports for Sources With Compliance Extensions.	Yes.	
§ 63.10(d)(5)	Startup, Shutdown, and Malfunction Reports.	Yes	Applies only to capture systems and add-on control devices used to comply with the standards.
§ 63.10(e)(1)–(2)	Additional CMS Reports	No	Subpart IIII does not require the use of continuous emissions monitoring systems.
§ 63.10(e)(3)	Excess Emissions/CMS Performance Reports.	No	Section 63.3120(b) specifies the contents of periodic compliance reports.
§ 63.10(e)(4)	COMS Data Reports	No	Subpart IIII does not specify requirements for opacity or COMS.
§ 63.10(f)	Recordkeeping/Reporting Waiver.	Yes	
§ 63.11	Control Device Requirements/ Flares.	No	Subpart IIII does not specify use of flares for compliance.
§ 63.12	State Authority and Delegations	Yes.	
§ 63.13	Addresses	Yes.	
§ 63.14	Incorporation by Reference	Yes.	
§ 63.15	Availability of Information/Confidentiality.	Yes.	

Table 3 to Subpart IIII of Part 63—Default Organic HAP Mass Fraction for Solvents and Solvent Blends

You may use the mass fraction values in the following table for solvent blends for which you do not have test data or manufacturer's formulation data $\frac{1}{2}$

Solvent/solvent blend	CAS. No.	Average organic HAP mass fraction	Typical organic HAP, percent by mass
1. Toluene	108-88-3	1.0	Toluene.
2. Xylene(s)	1330–20–7	1.0	Xylenes, ethylbenzene.
3. Hexane	110–54–3	0.5	n-hexane.
4. n-Hexane	110–54–3	1.0	n-hexane.
5. Ethylbenzene	100-41-4	1.0	Ethylbenzene.
6. Aliphatic 140		0	None.
7. Aromatic 100		0.02	1% xylene, 1% cumene.
8. Aromatic 150		0.09	Naphthalene.
9. Aromatic naphtha	64742–95–6	0.02	1% xylene, 1% cumene.
10. Aromatic solvent	64742–94–5	0.1	Naphthalene.
11. Exempt mineral spirits	8032-32-4	0	None.
12. Ligroines (VM & P)	8032-32-4	0	None.
13. Lactol spirits	64742–89–6	0.15	Toluene.
14. Low aromatic white spirit	64742-82-1	0	None.
15. Mineral spirits	64742–88–7	0.01	Xylenes.
16. Hydrotreated naphtha	64742-48-9	0	None.
Hydrotreated light distillate	64742–47–8	0.001	Toluene.
18. Stoddard solvent	8052-41-3	0.01	Xylenes.
19. Super high-flash naphtha	64742–95–6	0.05	Xylenes.
20. Varsol® solvent	8052-49-3	0.01	0.5% xylenes, 0.5% ethylbenzene.